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PATENT
Customer No. 22,852
Attorney Docket No. 04329.2348

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Iwao HIGASHIKAWA)
Application No.: 09/615,605) Group Art Unit: 2851
Filed: July 13, 2000) Examiner: Cruz, Magda
For: PATTERN FORMING METHOD AND)
LIGHT EXPOSURE APPARATUS)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

PETITION FOR EXTENSION OF TIME

Applicant hereby petitions for a two-month extension of time to reply to the Office Action of September 16, 2003. Since February 16, 2004 was a Federal holiday, the time for reply extends through February 17, 2004. A fee of \$410.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

Dated: February 17, 2004

By: *Richard V. Burgujian* *Reg 24,014*
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02/23/2004 MAHME1 00000053 060916 09615605

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